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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/720,388	11/25/2003	Hiroyuki Uwazumi	32307-198189	4270
26694	7590 06/28/2004		EXAMINER	
VENABLE	, BAETJER, HOWAR	FALASCO, LOUIS V		
P.O. BOX 34385 WASHINGTON, DC 20043-9998			ART UNIT	PAPER NUMBER
,			1773	
			DATE MAILED: 06/28/2004	1

Please find below and/or attached an Office communication concerning this application or proceeding.

	· · · · · · · · · · · · · · · · · · ·					
·1	Application No.	Applicant(s)				
Office Action Summers	10/720,388	UWAZUMI ET AL.				
Office Action Summary	Examiner	Art Unit				
	Louis Falasco	1773				
The MAILING DATE of this communicate Period for Reply	tion appears on the cover sheet with	h the correspondence address				
A SHORTENED STATUTORY PERIOD FOR THE MAILING DATE OF THIS COMMUNICA  - Extensions of time may be available under the provisions of 3 after SIX (6) MONTHS from the mailing date of this communic  - If the period for reply specified above is less than thirty (30) da  - If NO period for reply is specified above, the maximum statuto  - Failure to reply within the set or extended period for reply will,  Any reply received by the Office later than three months after the earned patent term adjustment. See 37 CFR 1.704(b).	TION. 7 CFR 1.136(a). In no event, however, may a rejection. ays, a reply within the statutory minimum of thirty ry period will apply and will expire SIX (6) MONT by statute, cause the application to become ABA	ply be timely filed  (30) days will be considered timely.  HS from the mailing date of this communication.  NDONED (35 U.S.C. § 133).				
Status						
1) Responsive to communication(s) filed o	n <u>28 January 2004</u> .					
2a) This action is <b>FINAL</b> . 2b)	This action is <b>FINAL</b> . 2b)⊠ This action is non-final.					
·	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.					
Disposition of Claims						
4) Claim(s) <u>5-8 and 10</u> is/are pending in the application.  4a) Of the above claim(s) is/are withdrawn from consideration.  5) Claim(s) is/are allowed.  6) Claim(s) <u>5-8 and 10</u> is/are rejected.  7) Claim(s) is/are objected to.  8) Claim(s) are subject to restriction and/or election requirement.						
Application Papers						
9) The specification is objected to by the E.  10) The drawing(s) filed on 25 November 20  Applicant may not request that any objection Replacement drawing sheet(s) including the 11) The oath or declaration is objected to by	2003 is/are: a)⊠ accepted or b)☐ n to the drawing(s) be held in abeyand e correction is required if the drawing(s	ce. See 37 CFR 1.85(a). c) is objected to. See 37 CFR 1.121(d).				
Priority under 35 U.S.C. § 119						
12)⊠ Acknowledgment is made of a claim for a)⊠ All b)□ Some * c)□ None of:  1.□ Certified copies of the priority documents. Certified copies of the priority documents.	cuments have been received. cuments have been received in Ap he priority documents have been r Bureau (PCT Rule 17.2(a)).	plication No. <u>09/789,928</u> . received in this National Stage				
Attachment(s)	_					
1) Notice of References Cited (PTO-892)  4) Interview Summary (PTO-413)  2) Notice of Draftsperson's Patent Drawing Review (PTO-948)  Paper No(s)/Mail Date						
<ol> <li>Notice of Draftsperson's Patent Drawing Review (PTO-3)</li> <li>Information Disclosure Statement(s) (PTO-1449 or PTO Paper No(s)/Mail Date 11/25/03.</li> </ol>		omal Patent Application (PTO-152)				

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This application is acknowledged as a Division of US 09/789928 now US Patent 6716542.

### PAPERS RECEIVED

Applicants' Information Disclosure Statement of 11/25/03 is acknowledged.

Applicants' Preliminary Amendment received 01/28/04 is acknowledged.

### **CLAIMS**

The claims are 5 to 8 and 10.

All claims are under consideration.

# **ACTIONS**

Statutory Basis

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

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#### Rejections

1. Claims 5 and 6 are rejected under 35 U.S.C. 103(a) as being unpatentable over **Howard et al** (US 5436047) taken with **Toshiya** (JA 2948019 - as cited in the instant specification, equivalent to applicants IDS published application JA 5-311413) in view of either **Thomas et al** (US 4675091) or **Mitsui** (US 6042752).

**Howard** teaches the process of these claims except the size of the particles used in the sputtering target. Howard teaches a method for producing a magnetic recording medium comprising a nonmagnetic undercoat on a substrate, a magnetic layer and a protective layer. The magnetic layer is formed by sputtering, where the target is composed of a metal and an oxide (see Howard Fig. 1 element and col. 3 lns 5-10). Howard does not teach the specific size of the metal and an oxide sputtering target of 10 µm or less. However Toshiya points out that the particle size of the metal and an oxide sputtering target as less than 20 μm (see Target E at Detailed Description paragraph [0023] of Toshiya) using a metal and oxide target such as Cr - Al<sub>2</sub>O<sub>3</sub> or Ta-SiO encompassed by the instant claims. This particle size is preferred to prevent detrimental arcing during sputtering (see Detailed Description paragraph [0008] and [0024]). Toshiya by teaching the use of a particle size lower than 20 µm includes the claimed particle size of 10 μm or less and the 5 μm or less in claim 6. Furthermore it has been

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generally recognized in the sputtering art that a even smaller sputter target particle size will reduce arcing as evident from either **Thomas et al** (col. 3 ln 50 – col. 4 ln 5 and in the Example at col. 5 ln 23) or **Mitsui** (col. 5 lns 1- 10 and in Examples at col. 9 lns 9 and 10).

It would have been obvious to one having ordinary skill in the art at the time the invention was made to adopt the size of the metal and an oxide sputtering target particle size of 10 μm or less and 5 μm or less in the process for making a magnetic recording media of Howard given the Toshiya teaching the use of a metal and oxide target particle size lower than 20 µm sputtering target. Toshiya points out the smaller size particle lower than 20 μm prevents detrimental arcing in the process (Toshiya 'Effect of the Invention' paragraph [0027]). Moreover **Thomas et al** and **Mitsui** show that reducing the size of the particle in the sputter target minimizes current jumps that reduce bond and uniformity of the coating (Thomas et al col. 3 lns 12-14; Mitsui col. 1 lns 53, 54 and col. 2 lns 23, 24). One skilled in the art would have been motivated to adopt Toshiya, reducing the size of the particle size in the sputter target below 20 µm in the sputter process for producing a magnetic recording element of the primary reference, with the expectation of preventing arcing to form a more strongly bonded more uniform coating in view of the appreciation in the sputtering art. It has been demonstrated by Thomas et al and Mitsui that decreasing the target particle size results in decrease of detrimental arcing.

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2. Claims 7, 8 and 10 are rejected under 35 U.S.C. 103(a) as being unpatentable over **Howard et al** taken with **Toshiya** in view of either **Thomas et al** or **Mitsui** as applied to claims 5 and 6 above, and further in view of **Katsutake et al** (JA 08-255342) or **Yusu et al** (US 6174597).

Howard et al taken with Toshiya in view of either Thomas et al or Mitsui do not show sputter coating a for a magnetic recording medium having Co and Pt with the metal oxide. However sputter coated magnetic recording media containing Co and Pt with a metal oxide are well know constituents conventional in the magnetic recording art, as demonstrated by Katsutake et al or by Yusu et al (see Katsutake et al Co and Pt compositions including oxides shown on Table 1, translation the *Means* paragraph, the *Examples* paragraph [0034] and Yusu et al col. 4 lns 12-21, col. 5 lns 47- 56 Example 1A, 3A, 3B, 4A).

It would have been obvious to one having ordinary skill in the art at the time the invention was made to adopt the convention demonstrated by **Katsutake et al** or by **Yusu et al** of having magnetic recording media containing

Co and Pt with the metal oxides of these claims in recording media such as **Howard et al** for the purpose of increasing the sensitivity and Signal-to-Noise ratio of the medium (**Katsutake et al** Detailed Description paragraph [0003],

Example paragraph [0022] or **Yusu et al** col. 1 ln 19, 20, 45, 46). One skilled in the

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art would have been motivated to adopt Katsutake et al or Yusu et al with the expectation of increasing recording quality while decreasing the signal noise.

### OTHER REFERENCES

All references from IDS have been considered.

#### **CONCLUSION**

The claims are 5 to 8 and 10.

All claims have been considered, no claim has been allowed in this action.

# **INQUIRES**

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Louis Falasco whose telephone number is (571)272-1507. The examiner can normally be reached on M-F 10:30 - 7:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Paul Thibodeau can be reached on (571)272-1516. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <a href="http://pair-direct.uspto.gov">http://pair-direct.uspto.gov</a>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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LF 6/04 STEVAN A. REŜAN PRIMARY EXAMINER